



## SEARCHED

Class	Sub.	Date	Exmr.
438	660 694 478-79 906 913 778	10/29/02	G
414	271,935		
118	215,800		
438 & 118	UPDATED	5/26/03	G

## INTERFERENCE SEARCHED

Class	Sub.	Date	Exmr.

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	Date	Exmr.
WAFER TRANSFER CHAMBER SUPPLY/EXHAUST INERT GAS WAFER PROCESSING VACUUM PUMP	10/29/02	G
ADD CONTINUOUS INERT GAS	5/26/03	G
TRANSLATED ORAL + WRITTEN	5/27/03	G

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